



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Noureddine BOUADMA

Serial No.: 10/066,641

Confirmation No.: 4521

Filed: February 6, 2002

For: BURIED RIBBON SEMICONDUCTOR
LASER AND A METHOD OF
FABRICATION

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: 2828

Examiner: AL NAZER, Leith A.

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited with
sufficient postage as first class mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on April 21, 2004.

Chance E. Hardie
Typed Name

Signature

SUBMISSION OF FORMAL DRAWING REPLACEMENT SHEETS

Attached please find four replacement sheets of formal drawings, with gummed labels identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

Any comparison fee should be charged to Deposit Account No. 20-0782/AVAN/000347. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at (713) 623-4844.

Respectfully submitted,

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